

Measurement of electron in-liquid amplification in pure argon

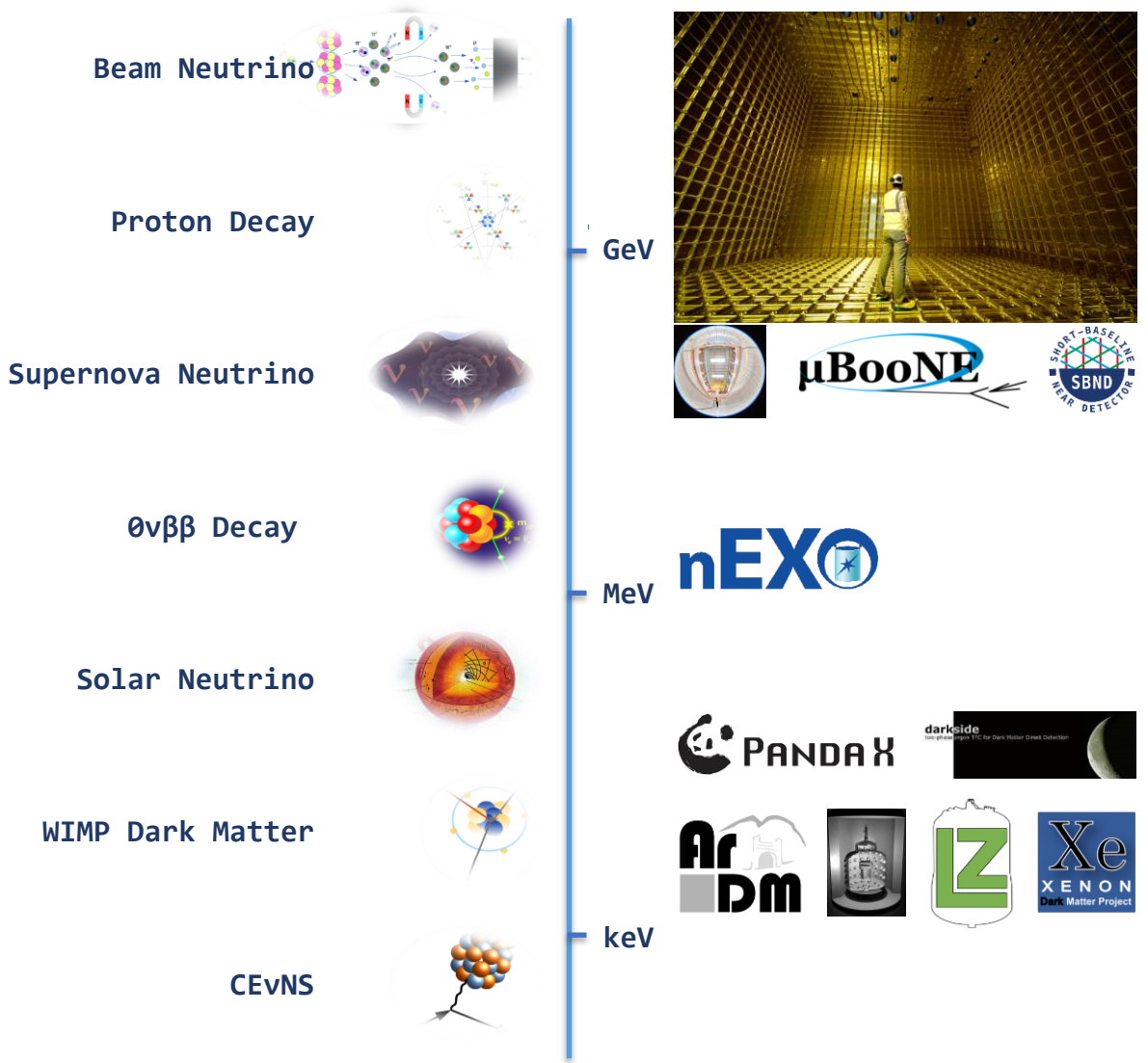
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Motivation for the measurement

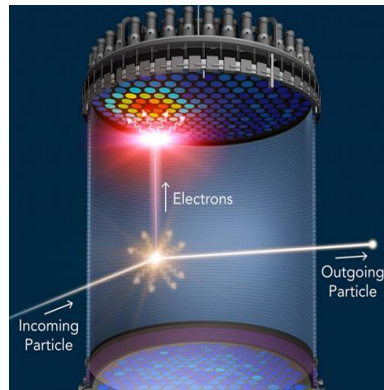
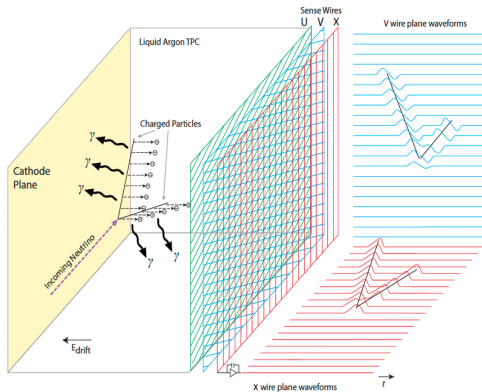
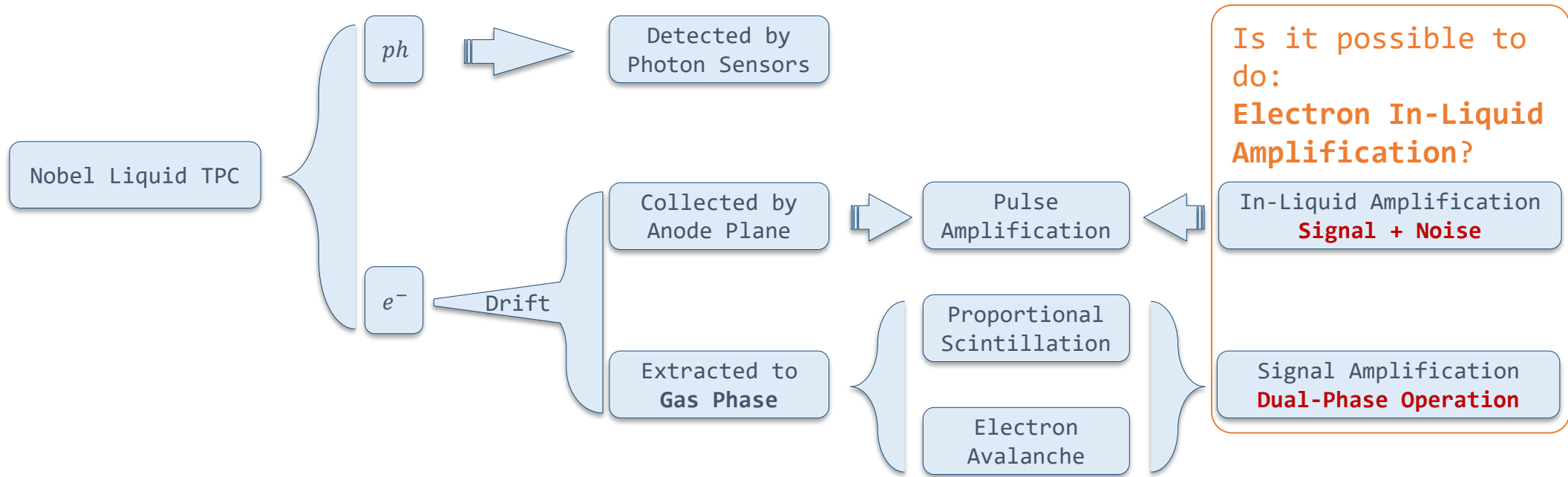


- Noble liquid TPC detectors are widely used for neutrino and dark matter physics, using:
 - Light
 - Charge

- Lots of efforts have been invested on improvement of:
 - Detector energy threshold
 - Signal-to-Noise ratio

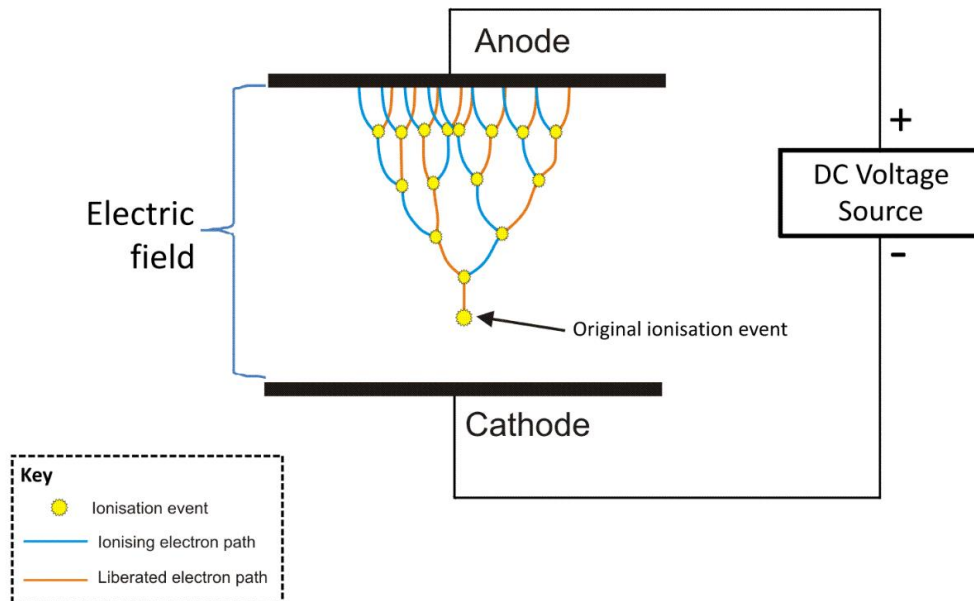
- Possible solution:
 - **Electron in-liquid amplification**

What is current design and limits?



Can charge be amplification in liquid before collection?

Past Research

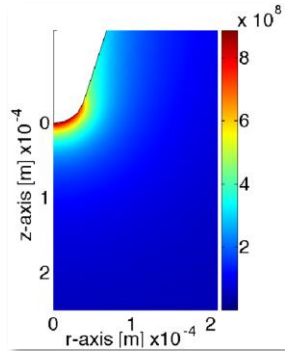


- Proportional Scintillation
 - Optical readout tracking detector concept using secondary scintillation from liquid argon generated by a thick gas electron multiplier
 - First demonstration of a bubble-assisted Liquid Hole Multiplier operation in liquid argon
 - Initial evaluation of proportional scintillation in liquid Xenon for direct dark matter detection
 - Measurements of proportional scintillation and electron multiplication in liquid xenon using thinwires
- Electron Avalanche
 - Electron multiplication in liquid argon on a tip array
 - Studies of electron avalanche behavior in liquid argon
 - Electron avalanches in liquid argon mixtures
 - LArCADE: Liquid Argon Charge Amplification Devices

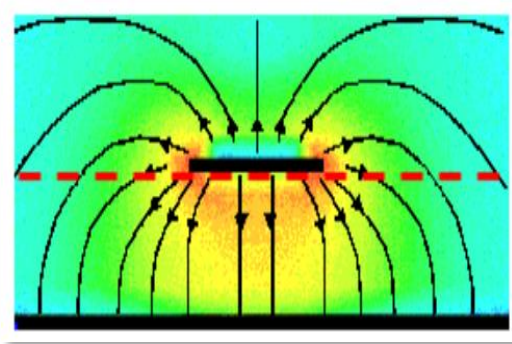
Will it occur in liquid noble element?

Let's measure it!

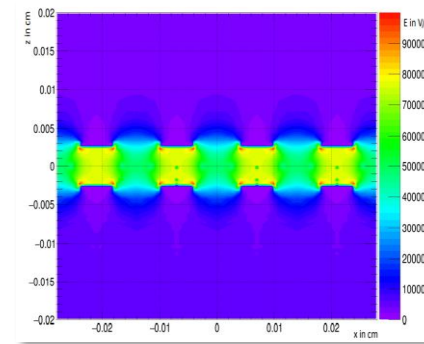
How to produce high electric field?



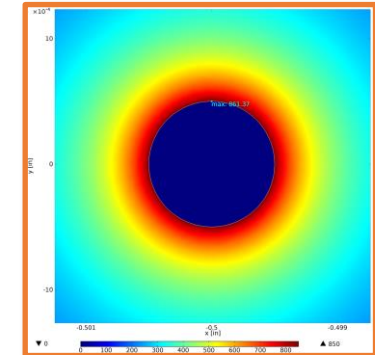
Needle Tip



Microstrip



(Thick) GEM

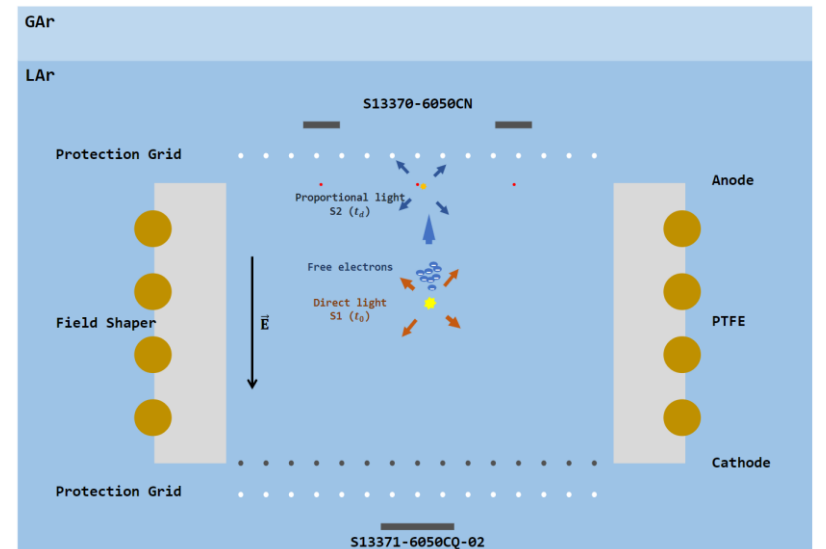
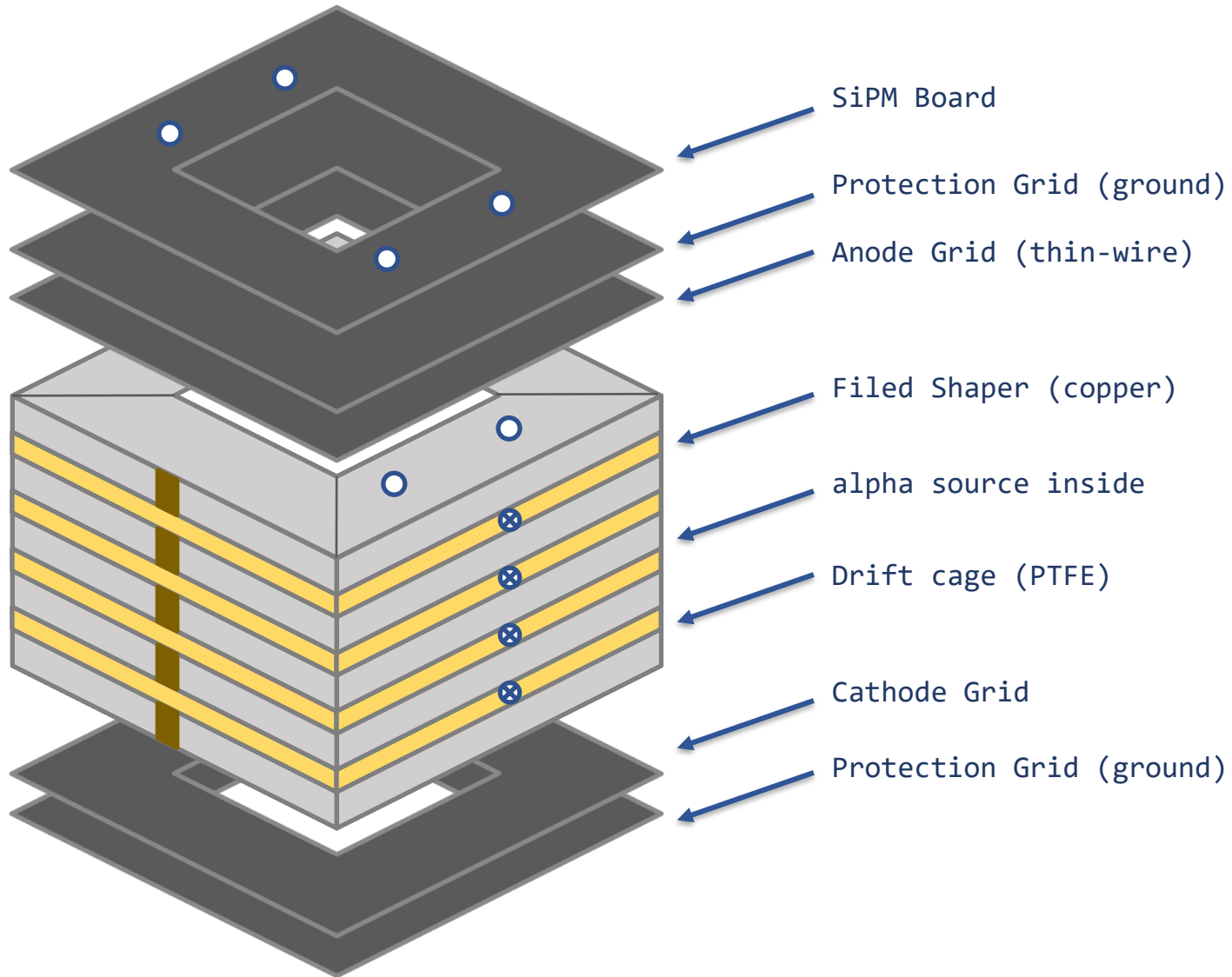


Thin Wire

Advantages of using thin wire ($\sim 10\mu\text{m}$) to produce high electric field

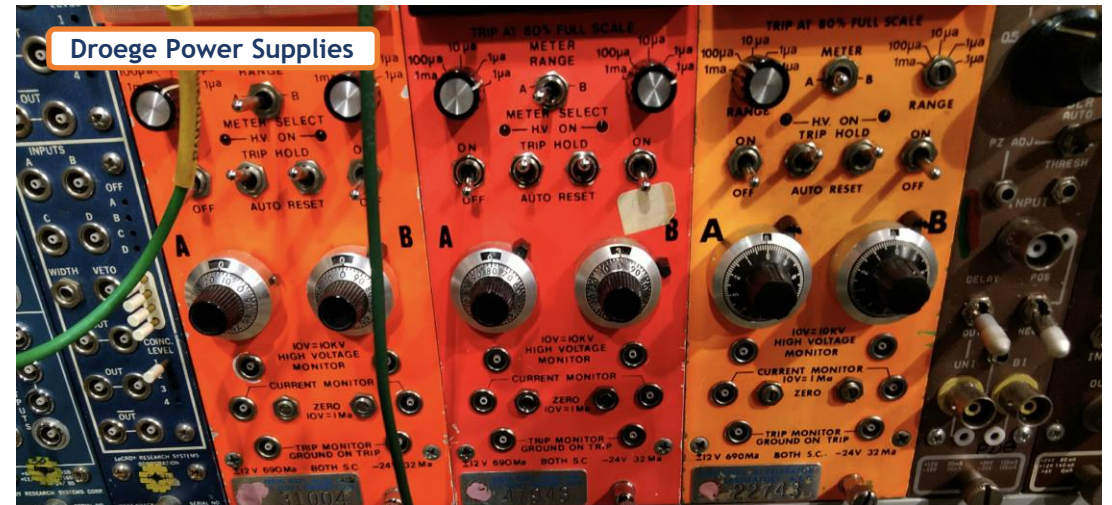
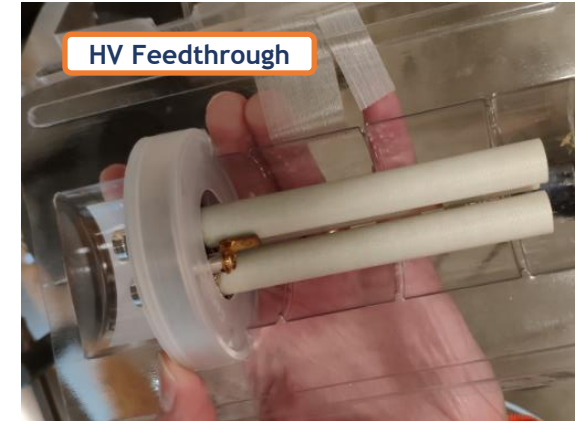
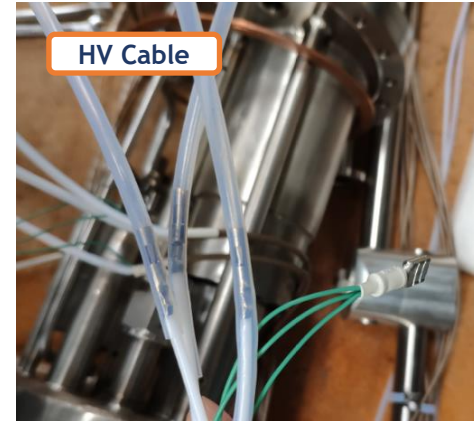
- Electric field produced by thin wire is easy to model and control
- The surface can be smooth without microscopic spurs or protrusions, which avoids local extremely high electric field
- There is no tip, which avoids corona discharge and reduces the heat input to avoid producing of bubble

Setup for the Measurement



Electric field production

- Positive/Negative Droege supplies
- SHV-5 Feedthrough
- From +3.5kV to -2.5kV
 - Trips >3.5kV
 - Sparks >-2.5kV
- E-Field
 - Drift field: **0.4 – 1.2 kV/cm**
 - Acceleration field: **1 – 2 MV/cm**



Anode kV	Cathode kV	Max Field* kV/cm	Drift Field kV/cm	Drift Velocity** cm/µs	Drift Time µs
2.0	0.0	1028.4	0.4	0.11	10.6
3.0	0.0	1542.6	0.6	0.14	8.6
3.5	0.5	1831.5	0.8	0.16	7.6
3.5	1.5	1895.2	1.0	0.18	6.9
3.5	2.5	1958.9	1.2	0.19	6.4

*Max field simulated by COMSOL Multiphysics

**Drift velocity calculated based on [liquid argon property](#)

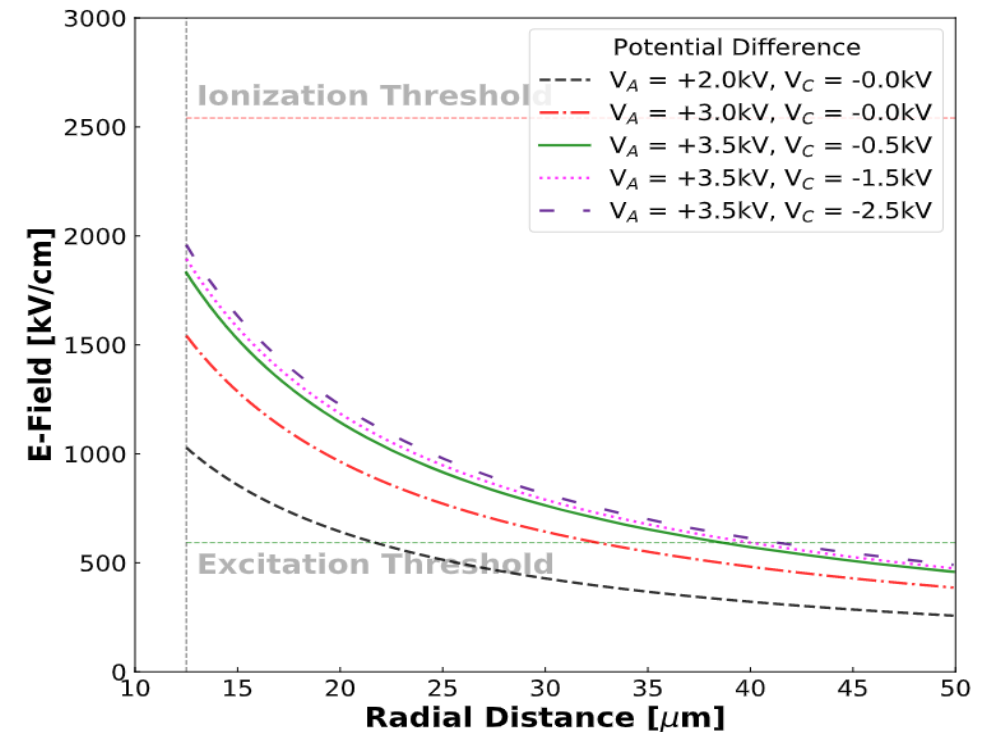
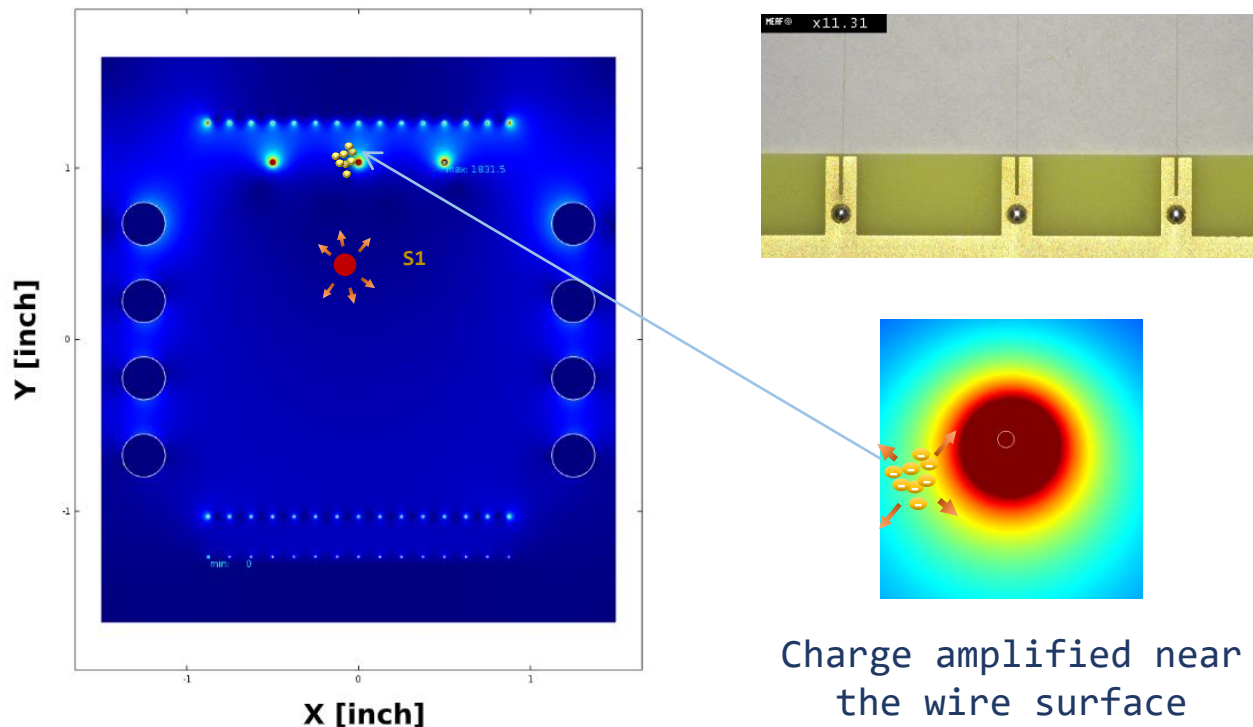
Principle for the measurement

^{241}Am α source

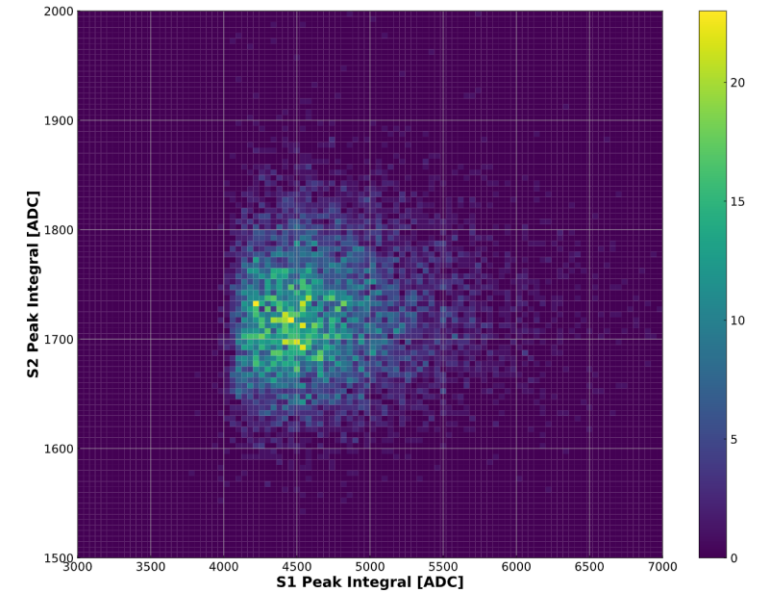
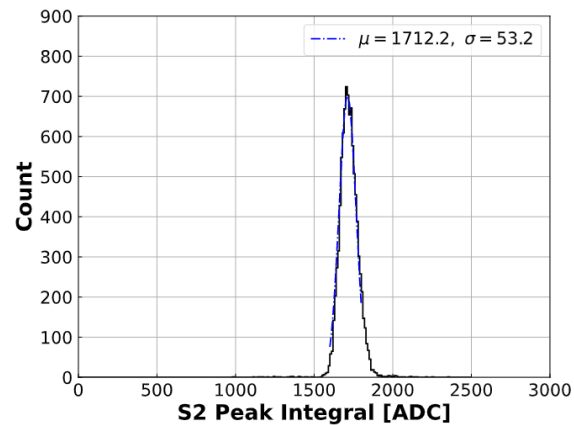
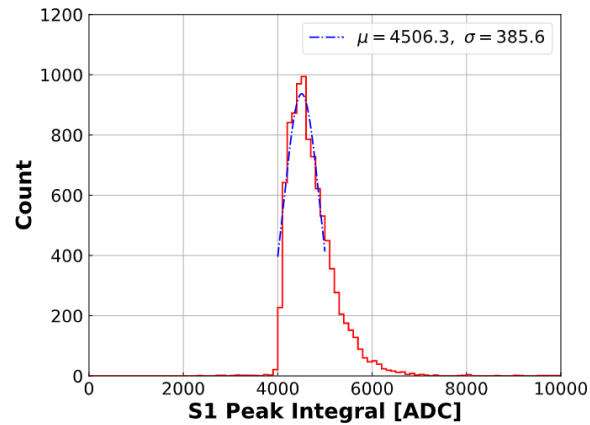
- Produce photons and electrons
- ~1-4% electrons escape from recombination under external electric field

High electric field

- GAR: homogeneous high field
- LAr: extremely high field near the surface of thin wires ($12\mu\text{m}$)



Initial measurement in liquid argon



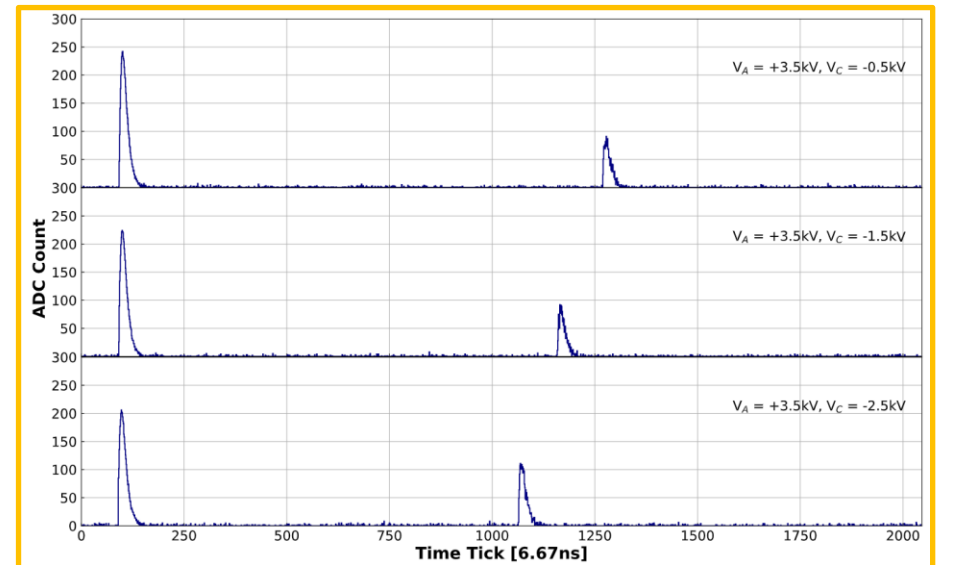
Threshold

Initial Measurement vs. Extrapolation (Gar* at 800bar)

- Proportional scintillation: ~ 1.8 vs ~ 0.6 MV/cm
- Electron avalanches: > 2.0 vs ~ 2.5 MV/cm

Gain

- Proportional scintillation: ~ 30 photons/electron



*Ref. threshold in gaseous argon

Future measurement

- A second cryogenic operation in pure argon to address issues with:
 - Liqui argon purity
 - High voltage feedthrough
 - Humidity of VUV4 SiPM sensors
- A third cryogenic operation in xenon-doped argon
 - Xe-doping increases the light yield and shifts the scintillation light wavelength from 128nm to 175nm;
 - Xe-doping is useful for quenching possible self-sustained discharges in argon